

<b>Notice of References Cited</b>		Application/Control No.	Applicant(s)/Patent Under Reexamination	
		10/697,094	SAGA ET AL.	
Examiner		Art Unit		Page 1 of 1
Natalia Figueiroa		2651		

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,741,524 B2	05-2004	Ichihara et al.	369/13.01
	B	US-6,795,380 B2	09-2004	Akiyama et al.	369/13.33
	C	US-6,636,460 B2	10-2003	Akiyama et al.	369/13.14
	D	US-6,584,062 B1	06-2003	Naya, Masayuki	369/112.27
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP2001-255254	09-2001	Japan	Takuya et al.	
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Nishida et al., "XY-stage Driving Electron-Beam Mastering with Nanometer-Accuracy Positioning for High-Density Optical Disk", July 2002, International optical Memory and Optical Data Storage Topical Meeting, pages 28-30.
	V	Ito et al., "Advanced Recording Method Using a Near-Field Optics and the GMR Head", May 2000, Conference Digest Optical Data Storage, pages 30-32.
	W	Sukeda et al., "Thermally assisted Magnetic Recording on Flux-Detectable RE-TM Media", July 2001, IEEE Transaction on Magnetics, Volume 37, Issue 4, pages 1234-1238.
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.